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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Shoriki NARITA et al. : Attn: BOX PCT
Serial No. NEW : Docket No. 2001_1876A
Filed January 2, 2002 :

BUMP FORMING APPARATUS FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVAL
METHOD FOR CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE,
CHARGE REMOVING UNIT FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, AND CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE
[Corresponding to PCT/JP00/04280
Filed June 29, 2000]

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Prior to initial examination of the above-identified application, kindly amend
the application as follows:

IN THE ABSTRACT:

Kindly replace the original abstract (page 151) with the enclosed substitut
abstract.

20010102-00251001